

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 04-02)

In the application of:
Hyung-guen Lee
Serial No.
Filed: February 11, 2004
For: Method and System for Luminance Noise
Filtering

Examiner:

Group Unit:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §§ 1.97 - 1.98, the Applicants wish to make the following documents of record in the above-identified application. This Information Disclosure Statement is in compliance with the duty of candor as set forth in 37 C.F.R. § 1.56. Copies of the documents cited below are enclosed. These documents are also listed on the enclosed PTO Form 1449.

In the judgment of the undersigned, portions of the listed documents may be material to the patentability of the presently pending claim. However, the documents have not been reviewed in sufficient detail to make any other representation and, in particular, no representation is intended as to the relative importance of any portion of the documents. This statement is not a representation that the listed documents have effective dates early enough to be "prior art" within the meaning of 35 U.S.C. § 102 or § 103.

List of Cited References

I. Patents

<u>Patent No.</u>	<u>Title</u>	<u>Inventors</u>
5,382,976	Apparatus and Method for Adaptive Interpolating a Full Color Image Utilizing Luminance Gradients	Hibbard
5,506,619	Adaptive Color Plan Interpolation In Single Sensor Color Electronic Camera	Adams, Jr. et al.
6,091,862	Pixel Interpolation Device and Pixel Interpolation Method	Okisu

II. Patent Application Publications

<u>Publication No.</u>	<u>Title</u>	<u>Inventors</u>
2003/0081465	Apparatus and Method for Processing Output from Image Sensor	Cho

Respectfully Submitted,

Date: February 11, 2004

By:

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FORM PTO-1449 (Rev. 2-32)		U.S. Department of Commerce Patent and Trademark Office		Atty. Docket No. 04-02	Serial No.
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Applicant: Hyung-guen Lee			
		Filing Date: February 11, 2004	Group:		

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number							Date	Name	Class	Subclass	Filing Date if Appropriate
	5	3	8	2	9	7	6	01/17/95	Hibbard	348	273	06/30/93
	5	5	0	6	6	1	9	04/09/96	Adams, Jr. et al.	348	272	03/17/95
	6	0	9	1	8	6	2	07/18/00	Okisu	382	300	11/19/97

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.).

			US Patent Application Publication No. 2003/0081465 to Cho, published on May 1, 2003				
EXAMINER			DATE CONSIDERED				

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.